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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Farnworth et al.

Serial No.: 09/589,841

Filed: June 8, 2000

For: STEREOLITHOGRAPHIC
METHODS FOR FORMING A
PROTECTIVE LAYER ON A
SEMICONDUCTOR DEVICE
SUBSTRATE AND SUBSTRATES
INCLUDING PROTECTIVE
LAYERS SO FORMED

Examiner: G. Lee

Group Art Unit: 2825

Attorney Docket No.: 3923US (99-0033)

CERTIFICATE OF MAILING

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August 22, 2002
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Deidra Pfeil

Typed/printed name of person whose signature is contained above

AMENDMENT

Box NON FEE-AMENDMENT
Commissioner for Patents
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed May 22, 2002, the three-month shortened statutory period for response to which expires on August 22, 2002.